

Notice of References Cited	Application/Control No. 10/761,186	Applicant(s)/Patent Under Reexamination NAGATOMO, HIROSHI	
	Examiner Heather A. Doty	Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,372,673	04-2002	Besser et al.	438/792
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	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.